

DEC 08 2005

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Venkat Selvaramanickam, et al.

Title: APPARATUS FOR AND METHOD OF CONTINUOUS HTS TAPE
BUFFER LAYER DEPOSITION USING LARGE SCALE ION BEAM
ASSISTED DEPOSITION

App. No.: 10/609,250

Filed: June 26, 2003

Examiner: Ram N. Kackar

Group Art Unit: 1763

Customer No.: 34456

Confirmation No.: 7760

Atty. Dkt. No.: 1014-SP101-US

MS AMENDMENT

Commissioner for Patents

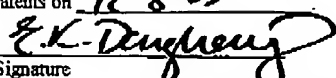
PO Box 1450

Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action mailed September 8, 2005, please amend the above-identified application as follows:

CERTIFICATE OF TRANSMISSION/MAILING	
I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to the Commissioner for Patents on <u>12-8-05</u>	
Elise K. Dougherty	
Typed or Printed Name	Signature